

19/23/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): GUOHENG ZHAO ET AL.
Assignee: KLA-TENCOR TECHNOLOGIES CORPORATION
Title: IMPROVED SYSTEM FOR MEASURING PERIODIC STRUCTURES
Serial No.: 09/742,029 Filing Date: December 20, 2000
Examiner: Unknown Group Art Unit: 2877
Docket No.: M-10696 US

San Jose, California

Aug ~~July~~ 1, 2001

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

LAW OFFICES OF
SKJERVEN MORRILL
MacPHERSON LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979



I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on AUGUST 1, 2001.

T. L. Kaplan
Tammy L. Kaplan

8/1/01
Date of Signature

Respectfully submitted,

James S. Hsue
James S. Hsue

Attorney for Applicants

Reg. No. 29,545

LAW OFFICES OF
SKJERVEN MORRILL
MacPHERSON LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979